

Damping Controller Design for Triangular Scanning of a Third-Order Nanopositioning Stage

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Abstract: In this paper, a design procedure of damping controller for third-order nanopositioning stage is presented for high-speed triangular scanning. Conventionally, damping control schemes of integral resonant control (IRC) and resonance-shifted IRC (RS-IRC) are designed providing that a second-order model can be identified for a nanopositioning stage. For a third-order system, existing control schemes cannot be applied directly. For this, a pole-zero cancellation technique is presented to design IRC scheme. In addition, a state observer based pole placement technique is proposed for RS-IRC design. The effectiveness of the proposed design procedures is demonstrated through both simulations and experiments based on a piezo-actuated nanopositioning stage platform. Results show that a closed-loop bandwidth of 156 Hz and 186 Hz are obtained by designed IRC and RS-IRC for the third-order nanopositioning stage, and the root-mean-square (RMS) errors of 40 Hz triangular tracking are 49 nm and 13 nm under IRC and RS-IRC control, respectively.

Keywords: Nanopositioning stage, Third-order system, Damping control, Integral resonant control, Observer design.

1. INTRODUCTION

Piezo-actuated nanopositioning stages are widely utilized to produce mechanical displacements with high resolution and high accuracy [1-3]. Owing to the merits of wide bandwidth, rapid response, and free friction [4, 5] of piezoelectric nanopositioning stages, successful applications can be found in abundant areas, including but not limit to scanning probe microscopy (SPM) [6, 7], micro electro mechanical systems (MEMS) [8], micromanipulators [9, 10], and data storage system [11]. However, the main challenge which restricts the motion speed lies in the lightly damped resonant modes of the compliant mechanism [3, 6-8, 11]. Unexpected structural vibrations may be easily excited at relatively low frequencies, which results in a significant loss of positioning bandwidth of the stage.

To address the vibration issue, both feedforward and feedback control approaches have been investigated [12, 13]. Feedforward strategies, such as inversion-based compensator [14], input shaping approach [15], iterative learning control with varying Q-filter [3], and iterative learning-based model predictive control [16], were proved effective in suppressing vibrational errors. An inherent drawback for a feedforward control approach is its high sensitivity to unmodelled dynamics and external uncertainties [12].

In view of that, various feedback schemes were proposed to damp the resonant modes. Some model-based methods like H_∞ control [17], linear quadratic Gaussian (LQG) control [6], output-feedback control using an

interval model [2], and recursive delayed position feedback (RDPF) control [18] were reported. Low robustness of systems with low Q-factor and high order of the synthetic controller are some of the disadvantages that the aforementioned methods may suffer from. A class of fixed-structure low-order controllers based on the negative-imaginary theory was developed. This theory is broadly applicable to problems of robust vibration control for flexible systems with lightly damped modes [19]. Earlier research efforts such as resonant control (RC) [20], positive position feedback (PPF) [21], and positive velocity and position feedback (PVPF) [22] have been studied with substantial improved performance. The advantage of adopting fixed-structure low-order control schemes makes them practically implementable and computationally efficient.

For a collocated system, another negative-imaginary based approach named integral resonant control (IRC) is shown to be effective to damp multiple modes simultaneously in the presence of model uncertainty [23]. The parameters of IRC for a second-order system can be easily chosen using an analytical approach as discussed in [24]. To make further increase of the positioning bandwidth, a resonance-shifted IRC (RS-IRC) scheme has been proposed in [25] by shifting the resonant frequency using a negative unity feedback loop. An important assumption for the above negative-imaginary based controllers is that the nanopositioning system can be identified or reduced as a second-order dynamic model [20-22] or a sum of several second-order dynamic models [23-25]. However, a general dynamic model of a piezo-actuated nanopositioning stage is third-order as pointed out in [26]. This makes the design methodology of IRC and RS-IRC in [23-25] inapplicable for the nanopositioning stages with

This work was supported by the Project funded by China Postdoctoral Science Foundation under Grant No. 2018M642907, Shenzhen Science and Technology Program under Grant No. JCYJ20170306171514468 and Natural Science Foundation of China under Grant No.51375349.

third-order models.

Hence, the motivation of this paper is to extend the damping controllers from second-order systems to third-order systems by applying a pole-zero cancellation technique and an observer based pole placement technique for IRC and RS-IRC design, respectively. To the best knowledge of the authors, few efforts have reported effective techniques for this issue except the PPF design for third-order systems in [26]. However, the structures of IRC and RS-IRC are totally different from that of PPF. We here propose the IRC and RS-IRC design procedures for fast tracking of a third-order nanopositioning stage, where the contributions are threefold: (1) a pole-zero cancellation technique is presented to design IRC for a third-order system; (2) a state observer based pole placement technique is proposed for RS-IRC design; (3) extensive experiments are conducted to evaluate the designed controllers based on a piezo-actuated nanopositioning platform.

The remainder of this paper is arranged as follows. Section II presents the experimental setup and the system identification. Section III briefly reviews the IRC and RS-IRC design procedures for second-order systems, and then the extension works of IRC and RS-IRC for a third-order system are discussed. Experimental results are shown in Section IV. Finally, Section V concludes this paper.

2. EXPERIMENTAL SETUP AND SYSTEM IDENTIFICATION

2.1 Experimental setup

Fig. 1 describes the physical experiment system employed in this work. A commercial model of a piezo-actuated nanopositioning stage (model: P-561.3CD, from Physik Instrumente Co., Ltd.) is utilized to validate the proposed design methods of IRC and RS-IRC for three-order systems.

The signal flow of the control loop is shown in Fig. 1(b). For each axis, the control input voltage with a range of 0-10 V is produced by 16-bit digital to analog interfaces (DACs) of the data output module in real-time controller (model: MicroLabBox, from dSPACE Co., Ltd.). A piezo amplifier module (model: E-503.00, from Physik Instrumente Co., Ltd.) with a fixed gain of 10 amplifies the input voltage and generates excitation voltage between 0 to 100 V. The output of each motion axis with a stroke of 100 μm , which is read by a PZT servo submodule (model: E-509.C3A, from Physik Instrumente Co., Ltd.), is subsequently passed to the data input module in dSPACE MicroLabBox with 16-bit analog to digital interfaces (ADCs). The control algorithm is designed in MATLAB/Simulink block diagram on the host PC, and then downloaded and executed on the target dSPACE MicroLabBox in the real-time software environment of dSPACE ControlDesk.

It should be noted that, in this work, only the z -axis in the vertical direction was utilized to implement the designed controllers for the nanopositioning system. The sampling frequency of the control loop was set as 10 kHz.

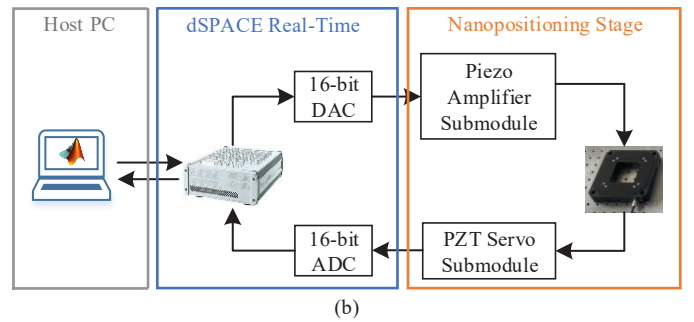
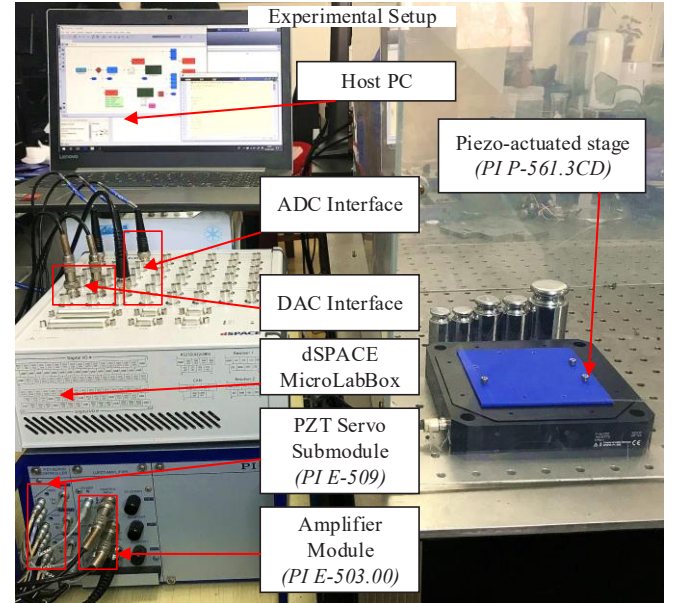


Fig. 1 Experimental setup of a piezo-actuated nanopositioning system: (a) experimental platform; (b) signal flow.

2.2 System identification

A chirp signal with a constant amplitude at 200 mV from 0 ~ 500 Hz was fed into the z -axis. A low magnitude of input voltage was used here to avoid distortion from hysteresis. A linear time invariant (LTI) models from the input voltage to the output displacement of the axes are obtained using the Identification Toolbox of MATLAB, which can be shown as

$$G(s) = \frac{21.4s^2 - 8.45 \times 10^4 s + 2.93 \times 10^8}{(s + 250.5)(s^2 + 114s + 1.751 \times 10^6)} \quad (1)$$

where $G(s)$ stands for continuous transfer function from the input voltage [V] to the output displacement [μm] of z -axis.

The comparative bode diagrams of the identified model and measured data are displayed in Fig. 2. It can be clearly found that the identified model accurately matches the measured dynamics of the system in the frequency range from 1 to 500 Hz. As described in (1), the real pole results in a drop before the resonant peak as can be seen in Fig. 2. This is the general bode diagram of a third-order nanopositioning system, which is quite different from second-order systems in [24] and [25]. Therefore, the design methods of IRC and RS-IRC in [24] and

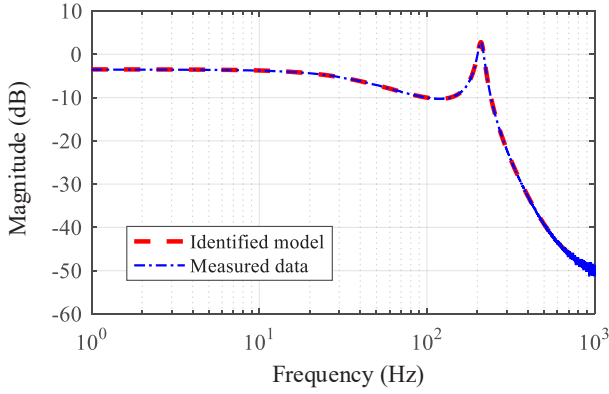


Fig. 2 Comparative bode diagrams of the identified model and measured data.

[25] can not be directly adopted for the third-order system in this paper.

3. CONTROLLER DESIGN FOR THIRD-ORDER SYSTEMS

Before introducing damping controller design for third-order systems, a brief review of conventional IRC and RS-IRC schemes are presented in this section.

3.1 Conventional IRC and RS-IRC

As shown in Fig. 3a, the IRC scheme for second-order systems mainly consists of two loops. The inner positive feedback loop is utilized to damp the resonant peak so that the working bandwidth can be increased. A feedthrough term is added parallelly with the second order system to add a pair of zeros corresponding to the resonant poles. A damping controller C_d is designed and tuned to achieve a maximum damping ratio for the resonant peak. The outer negative loop is added to minimize the tracking errors especially in the low frequency range. Normally, an integral type C_t can be adopted. For the details of parameters' determination, readers can refer to the analysis in [24].

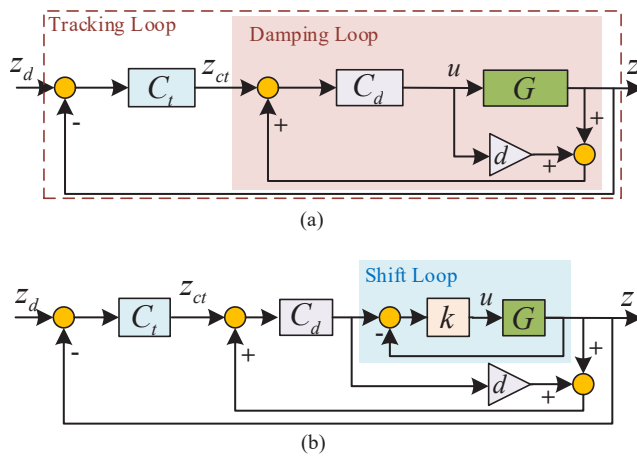


Fig. 3 Conventional IRC and RS-IRC schemes for second-order systems. (a) IRC; (b) RS-IRC.

On the basis of IRC scheme, the resonance-shifting integral resonant control scheme was proposed in [25].

Compared with Fig. 3a, an inner negative feedback loop is added for resonance-shifting. The shifter k is a positive gain which not only shifts the resonance peak but also increases the maximum peak value at the resonant frequency. The choice of k should make sure that the shifted resonance is within the sensor bandwidth as discussed in [25]. The remind parts of RS-IRC are the same with those of IRC.

The IRC has a better robustness performance than RS-IRC, while the bandwidth of is enhanced from IRC to RS-IRC. For the controller designers, a choice of IRC or RS-IRC can be made by evaluating the requirments for specific performance.

It should be noted that for third-order systems as described in (1), the IRC scheme can not be applied directly. In addition, the added shift loop in RS-IRC is always stable for a second-order system but unstable for a third-order system. Hence, the extension from second-order to third-order is meaningful for broadening the applications of IRC damping techniques.

3.2 IRC scheme for third-order systems

Inspired by the extension work of PPF in [26], we adopt the same operation that decomposing the third-order system G in (1) into a first-order system G_1 and a second-order system G_2 as,

$$G(s) = G_1(s) \cdot G_2(s) \quad (2),$$

where $G_1(s) = \frac{k_1}{s+p_1}$, and $G_2(s) = k_2 \frac{s^2+2\zeta\omega_z s+\omega_z^2}{s^2+2\xi\omega_p s+\omega_p^2}$.

From previous studies of the authors, it is found that the second-order component G_2 dominates the final dynamic responses of G . In addition, the first-order component G_1 is insensitive to external uncertainties such as load variation, temperature change or micro disturbance, etc. Herein, for the identified first-order component G_1 , a pole-zero cancellation technique can be utilized to remove the effect of the first-order pole. As shown in Fig. 4, to keep the controller rational, a filter Q is added in both the two parallel feedthrough loops. A simple integral $Q = 1/s$ is utilized in this work to minimize the tracking errors in the inner damping loop.

Hereto, the original third-order system is reduced to a second-order system in the IRC scheme. The analytical approach in [24] can then be applied into the deisgn of remind parts in the modified IRC scheme for third-order systems.

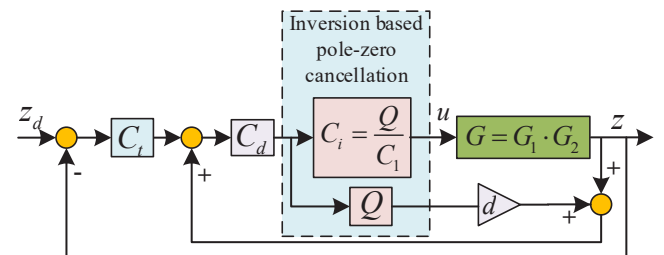


Fig. 4 Modified IRC scheme for third-order systems.

The design procedure for the proposed IRC for third-order systems can be summarized as follows:

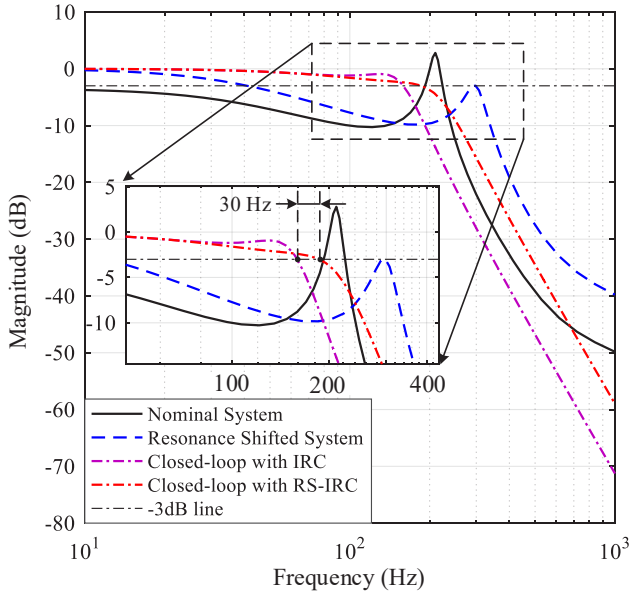


Fig. 7 Bandwidth test of open-loop and closed-loop systems with IRC and RS-IRC.

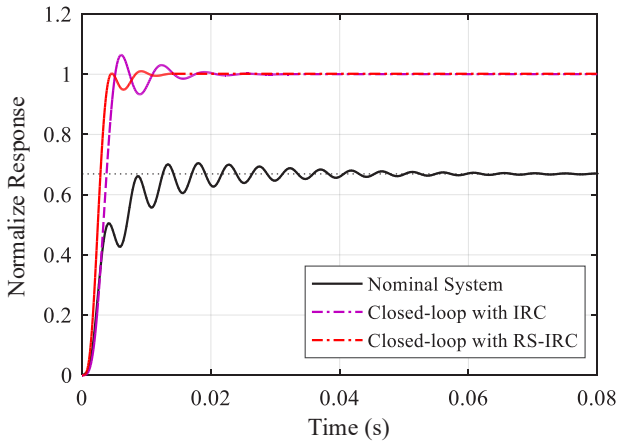


Fig. 8 Step responses of open-loop and closed-loop systems with IRC and RS-IRC.

4.3 Experiments for triangular tracking test

Triangular tracking is a common scanning mode for piezo-actuated nanopositioning in SPM. The triangular signal consists of a fundamental frequency and its odd harmonics, which are much higher than the fundamental frequency. Considering the achieved closed-loop bandwidth of the designed IRC and RS-IRC, 40 Hz triangular scanning is input for experiments.

Tracking results for both open-loop and closed-loop systems are recorded in Fig. 9. It can be seen that closed-loop with RS-IRC performs best among the three scenarios. The overshoot is evident for designed IRC as is consistent with the step responses in Fig. 8. The root-mean-square (RMS) errors for IRC and RS-IRC are 49 nm and 13 nm, where a 73% improvement is obtained from IRC to RS-IRC.

To sum up, based on the simulations and experiments, the proposed IRC and RS-IRC schemes in Fig. 4 and 6

are effective for a third-order nanopositioning stage.

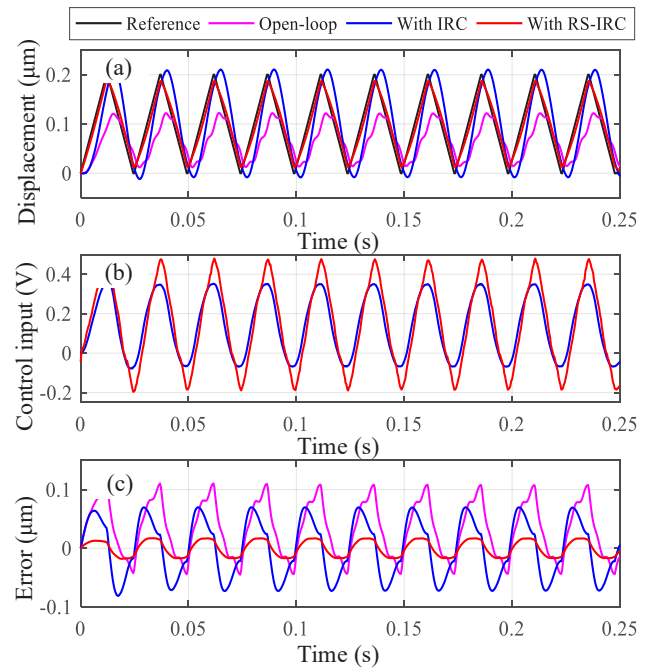


Fig. 9 Tracking results of 40 Hz triangular scanning of open-loop and closed-loop systems with IRC and RS-IRC.

5. CONCLUSIONS

The design procedures of IRC and RS-IRC for third-order nanopositioning systems are investigated in this paper. The main contributions are described in Fig. 4 and 6, where a pole-zero cancellation technique is proposed for IRC design and a state observer based pole placement technique is proposed for RS-IRC design. Detailed design procedures are also summarized for controller practitioners. It should be noted that the proposed techniques are not only applicable for IRC and RS-IRC as proved through simulations and experiments in this paper, but also fit for other fixed-structure low-order damping controllers' design such as RC, PPF, PVPF etc.

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